

PATENT  
Atty. Dkt. No. AMAT/4714.P1/W&T/MCVD/PJS

#19/B

www.ck12.org

**Examiner:** Zarneke, D.

**For: Method and Apparatus for Depositing Refractory Metal Layers Employing Sequential Deposition Techniques to Form a Nucleation Layer**

TECHNOLOGY CENTER 2800  
SPECIAL PROGRAM CENTER

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-305-1034 to the attention of the named Examiner, on the date below.

Keith R. Zuber  
Signature

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 5 of this paper.